



GEANT4
A SIMULATION TOOLKIT

Version 10.7

Electromagnetic Physics

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Geant4 Advanced Course

4-8 October 2021



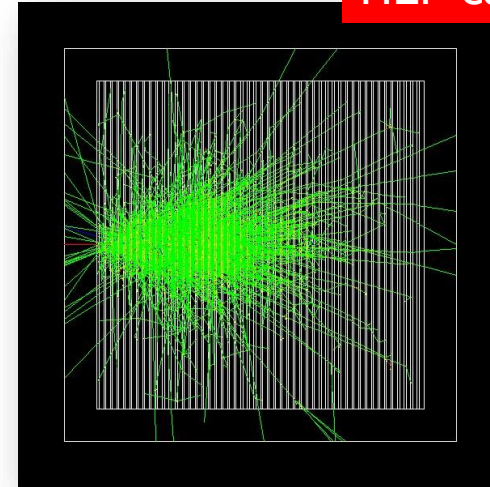
SLAC

- Electromagnetic physics (EM) overview
- Main Gamma processes
- Main charged particle processes
- Secondary production thresholds
- EM physics constructors
- User interface to EM physics
- Special EM topics

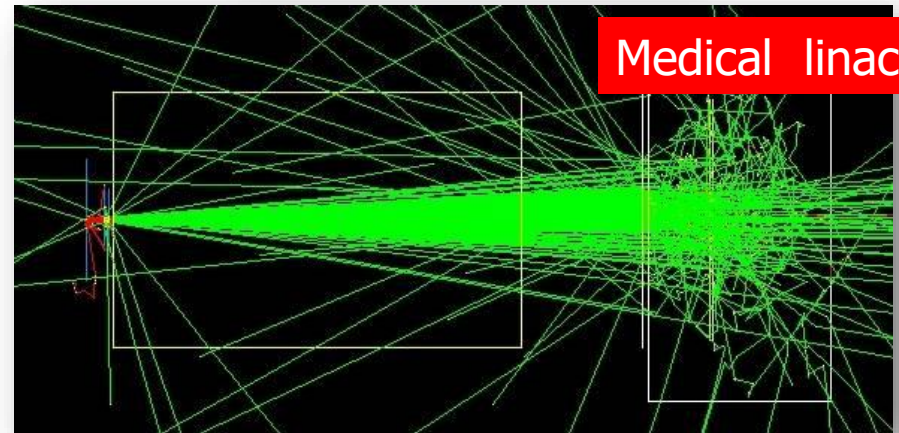
ELECTROMAGNETIC (EM) PHYSICS OVERVIEW

- Photon processes
 - γ conversion into e^+e^- pair
 - Compton scattering
 - Photoelectric effect
 - Rayleigh scattering
 - *Gamma-nuclear interaction in **hadronic sub-library***
- Electron and positron processes
 - Ionization
 - Coulomb scattering
 - Bremsstrahlung
 - *Nuclear interaction in **hadronic sub-library***
 - Positron annihilation
- Suitable for **HEP & many other Geant4 applications** with electron and gamma beams

HEP calorimeter



Medical linac

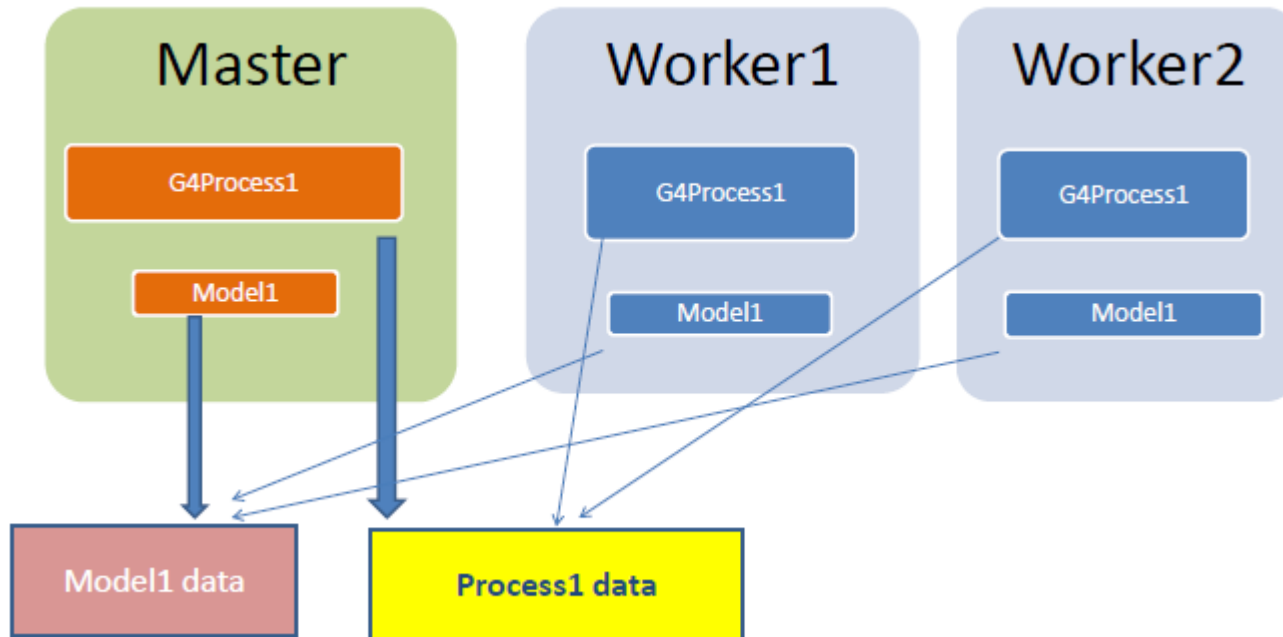


Located in \$G4INSTALL/sources/processes/electromagnetic

- **Standard**
 - γ , e up to 100 TeV
 - hadrons up to 100 TeV
 - ions up to 100 TeV
- **Muons**
 - up to 1 PeV
 - energy loss propagator
- **X-rays**
 - X-ray and optical photon production processes
- **High-energy**
 - processes at high energy ($E > 10 \text{ GeV}$)
 - physics for exotic particles
- **Polarisation**
 - simulation of polarised beams
- **Optical**
 - optical photon interactions
- **Low-energy**
 - Livermore library γ , e- from 10 eV up to 1 GeV
 - Livermore library based polarized processes
 - PENELOPE 2008 code rewrite , γ , e- , e+ from 250 eV up to 6 GeV
 - hadrons and ions up to 1 GeV
 - atomic de-excitation (fluorescence + Auger)
- **DNA**
 - Geant4 DNA modes and processes
 - Micro-dosimetry models for radiobiology
 - from 0.025 eV to 10 MeV
 - many of them material specific (water)
 - Chemistry in liquid water
- **Adjoint**
 - sub-library for reverse Monte Carlo simulation from the detector of interest back to source of radiation
- **Utils** : general EM interfaces and helper classes

- The uniform coherent approach for all EM packages
 - low energy and high energy models may work together
- A physical interaction or process is described by a process class
 - For example: G4ComptonScattering
 - Assigned to Geant4 particle types in Physics List
 - Three EM base processes:
 - G4VEmProcess
 - G4VEnergyLossProcess
 - G4VMultipleScattering
- A physical process can be simulated according to several models
 - each model being described by a model class
 - Naming scheme : « G4ModelNameProcessNameModel »
 - For example: G4LivermoreComptonModel
 - Models can be assigned to certain energy ranges and G4Regions
 - Inherit from G4VEmModel base class
- Model classes provide the computation of
 - Cross section and stopping power
 - Sample selection of atom in compound
 - Final state (kinematics, production of secondaries...)

- The scalability of Geant4 application in the MT mode depends on how effectively data management is performed
- Shared EM physics data:
 - tables for cross sections, stopping powers and ranges are kept by processes
 - Differential cross section data are kept by models
 - Material properties are in material data classes
 - EM parameters established for Physics Lists in the `G4EmParameters` class



Tables are filled by Master and have read-only access in run time

In this scheme number of threads is not limited

Main Gamma Processes

- Photo-effect is the main process for absorption of low-energy gamma
 - Rayleigh scattering should not be neglected if an accurate dosimetry simulation is needed
- At high energy gamma conversion dominates
- Gammas may be absorbed by nuclei due to giant dipole resonance

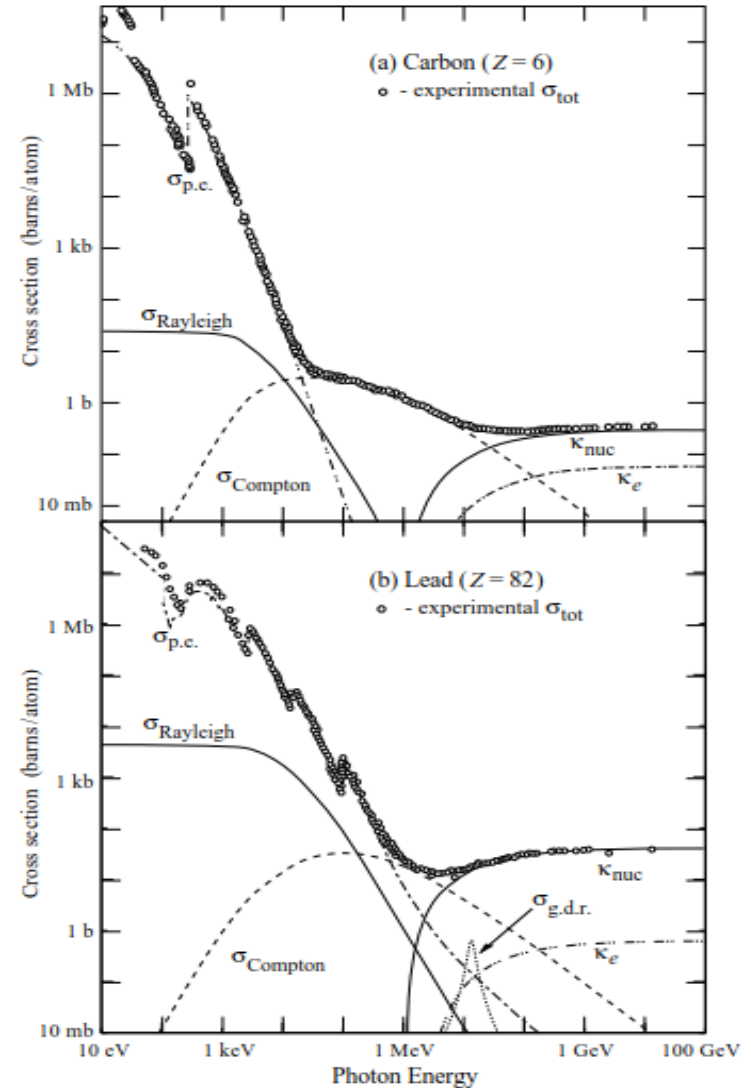
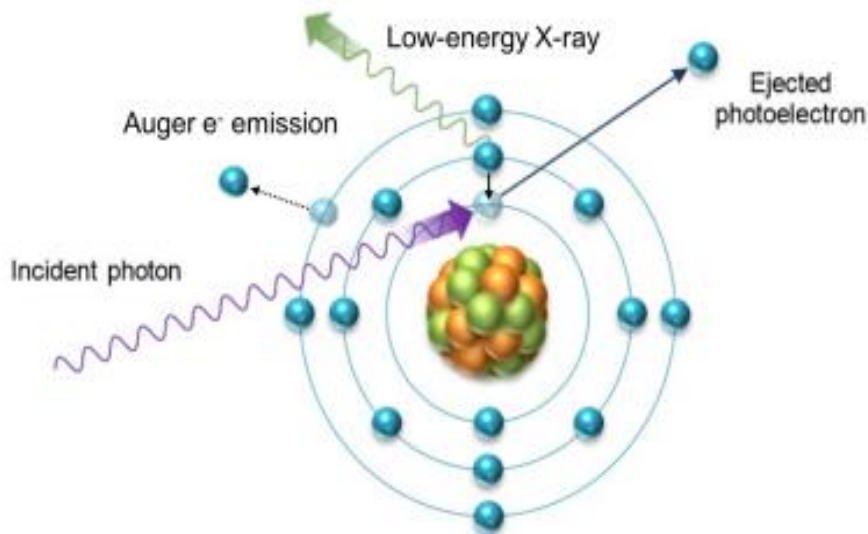
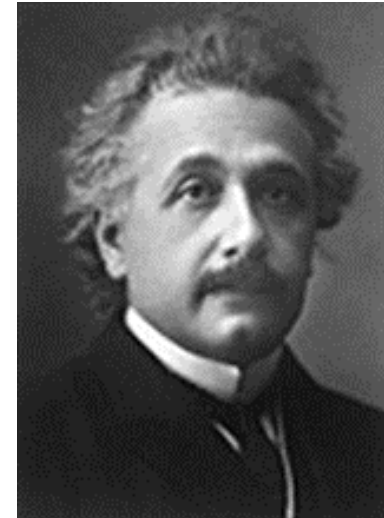


Photo-electric effect – example of gamma process

In the photo-electric absorption process a **photon is absorbed** by an atom and an **electron is emitted** with an energy:

$$E_{photoelectron} = E_{\gamma} - B_{shell}(Z_i) \quad (1)$$

The atom, left in an excited state with a vacancy in the ionized shell, decays to its ground state through a cascade of radiative and non-radiative transitions with the **emission of characteristic x-rays** and **Auger and Coster-Kronig electrons**.



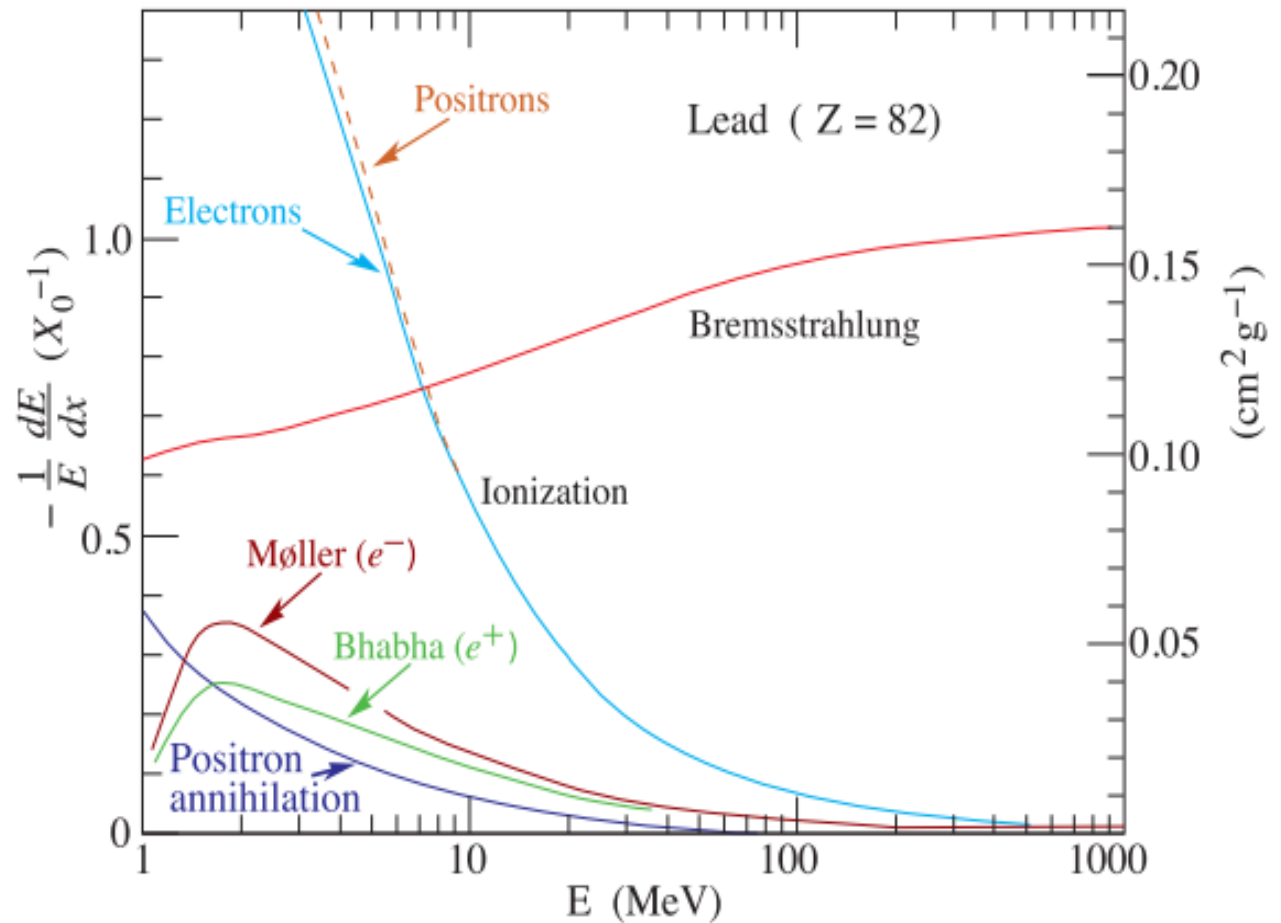
- Atomic de-excitation is initiated by other EM physics interactions:
 - e.g. photoelectric effect, ionisation (by e- or ions e.g. PIXE)
 - these interactions leave the target atom in an excited state
- The EADL (Evaluated Atomic Data Library) contains transition probabilities:
 - radiative transition i.e. characteristic X-ray emission (fluorescence photon emission)
 - Auger e- emission: initial and final vacancies are in different shells
 - Coster-Kronig e- emission: initial and final vacancies are in the same shells
- Due to a common interface, the atomic de-excitation is compatible with both the standard and the low-energy EM physics categories:
 - can be enabled and controlled by UI command (before initialization):

```
/process/em/fluor true  
/process/em/auger true  
/process/em/pixe true  
  
/run/initialize
```

- fluorescence transition is active by default in some EM physics constructor (e.g. the combined EM physics constructors) while others (Auger, PIXE) not

Main Charged Particle Processes

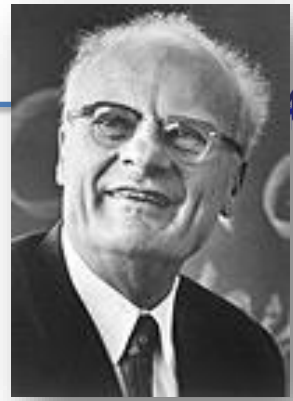
- At low energies ionisation dominates
- Above critical energy bremsstrahlung is the main process
 - Radiation energy loss exceeds ionization energy loss



Simulation of a step of a charged particle

- Values of **mean dE/dx , range, cross section of δ -electron production, and bremsstrahlung** are **pre-computed at initialisation stage** of Geant4 and are stored in a **G4PhysicsTable**
- **At run time** for each simulation step, a spline interpolation of tables is used to get **mean energy loss**
- At each step, a sampling of the **energy loss fluctuation** is performed
 - The interface to a fluctuation model is **G4VEmFluctuationModel**
- The cross sections of δ -electron production and bremsstrahlung are used to **sample production above the threshold T_{cut}** at **PostStep**
- If atomic de-excitation is active, then **fluorescence and Auger electron production** is sampled **AlongStep**

Hadron and ion ionisation



- Bethe-Bloch formula with corrections used for $E > 2$ MeV

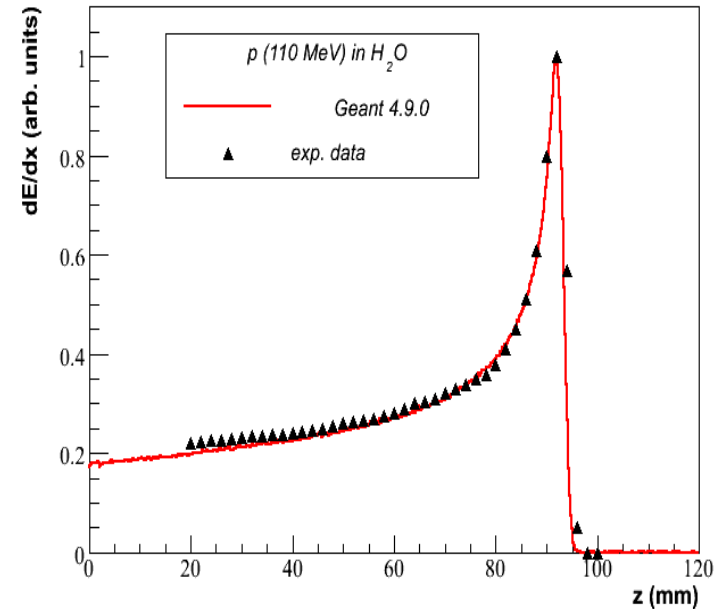
$$-\frac{dE}{dx} = 4\pi N_e r_0^2 \frac{z^2}{\beta^2} \left(\ln \frac{2m_e c^2 \beta^2 \gamma^2}{I} - \frac{\beta^2}{2} \left(1 - \frac{T_c}{T_{\max}} \right) - \frac{C}{Z} + \frac{G - \delta - F}{2} + zL_1 + z^2L_2 \right)$$

- C - shell correction
- G - Mott correction
- δ - density correction
- F - finite size correction
- L_1 - Barkas correction
- L_2 - Bloch correction
- Nuclear stopping
- Ion effective charge

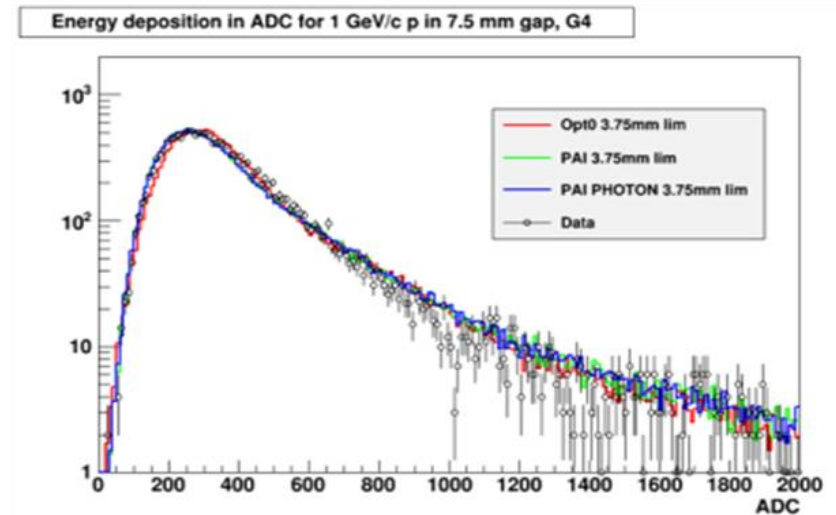
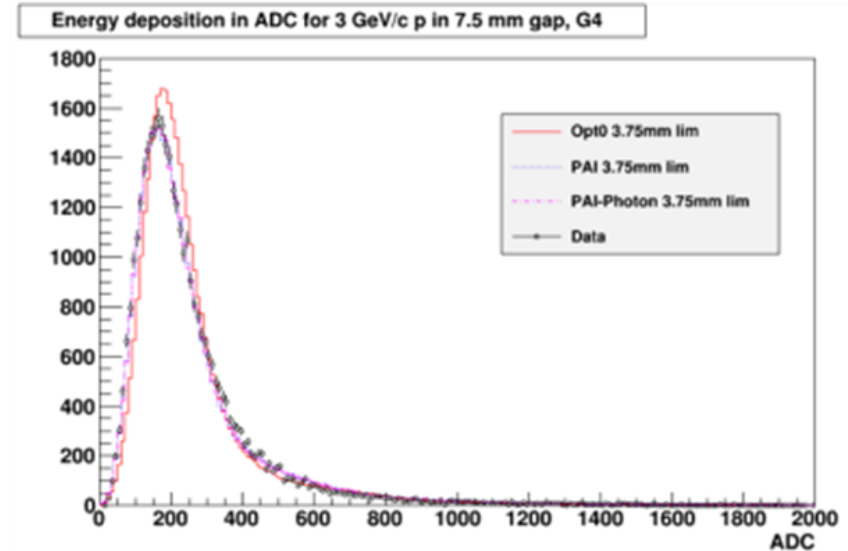
- Bragg peak parameterizations for $E < 2$ MeV
 - ICRU'49, ICRU'90, and NIST databases

- Scaling relation for heavy particles:

- $S_h(E) = S(E * M_p / M_h) * Q_h^2$,
- M_h, Q_h - hadron mass and charge
- Applicable to any charged particle including exotics and all ions
- This is possible, because dE/dx depend mainly on β

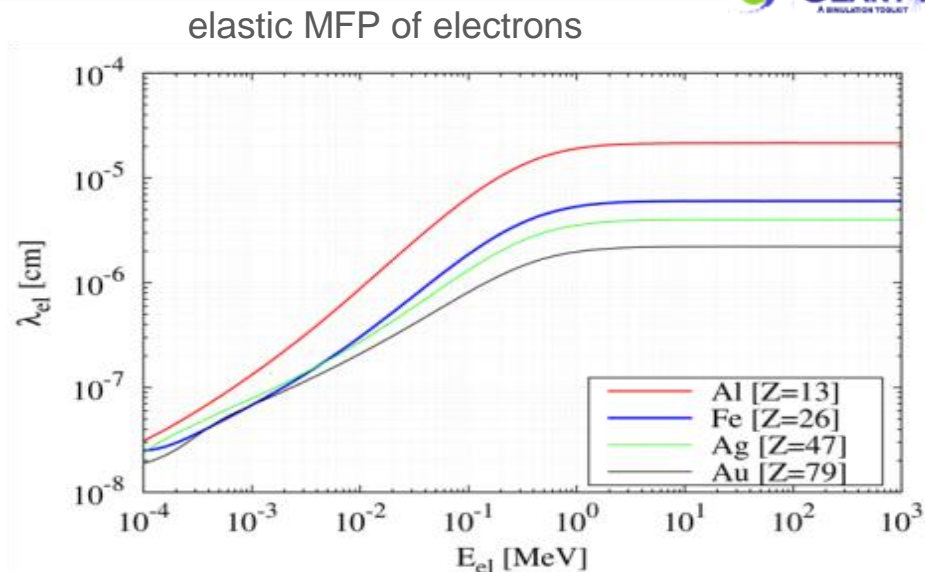


- **Urban model** based on a simple model of particle-atom interaction
 - Atoms are assumed to have only two energy levels E_1 and E_2
 - Particle-atom interaction can be:
 - an excitation of the atom with energy loss $E = E_1 - E_2$
 - an ionization with energy loss distribution $g(E) \sim 1/E^2$
- **PAI model** uses photo absorption cross section data
 - Energy transfers are sampled with production of secondary e^- or γ
 - Relativistic model
 - Very slow model, should be applied for sensitive region of detector

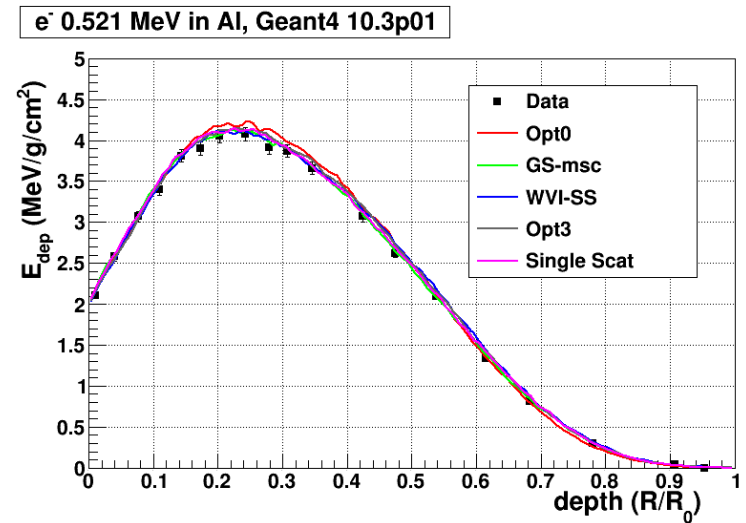
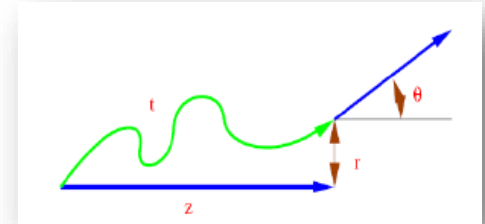


Multiple Coulomb scattering

- **Coulomb scattering**: elastic scattering of charged particles on the atomic potential
- **Event-by-event modelling of elastic scattering** is feasible only if the mean number of interactions per track is below few hundred
- **this limits the applicability of the detailed simulation model only for electrons with relatively low kinetic energies**
 - up to 100 keV) or thin targets
- **detailed simulation becomes very inefficient, high energy particle transport simulation codes employ condensed history simulation model**
 - **multiple scattering (MSC)** model is a solution
 - each track is simulated taking into account many elastic scattering at a step
- **A summary effects of high number of elastic interactions is in**
 - angular deflection of the particle
 - spatial displacement of the track post step point
 - increased effective track length



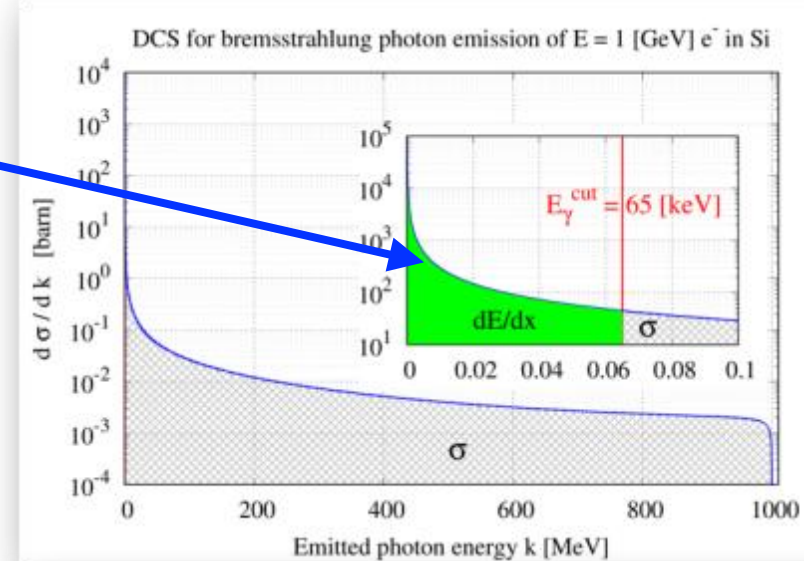
- The algorithm performs simulation of many elastic scatterings at a step of a particle
 - The physics processes and the geometry select the step length; MSC performs the $t \leftrightarrow z$ transformation only
 - Sampling of scattering angle (θ , Φ)
 - Computing of displacement and relocation of particle AlongStep
- To provide accurate simulation on geometry interface between different materials MSC step limitation is applied
 - Simple
 - UseSafety
 - UseSafetyPlus
 - UseDistanceToBoundary
- Other step limit parameters:
 - **RangeFactor** – is the most important
 - Geometry factor
 - Skin



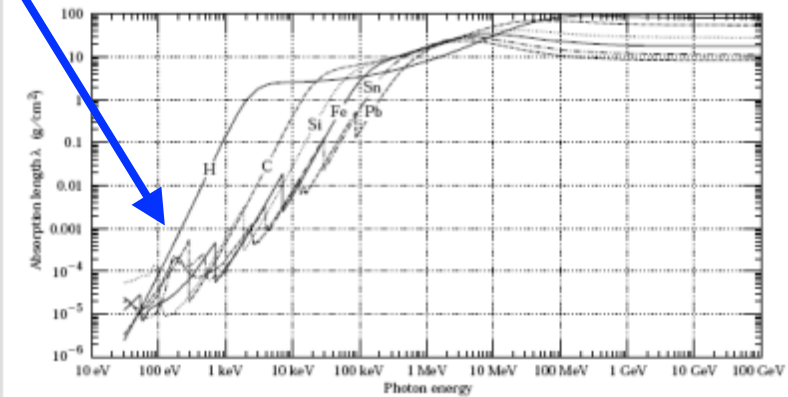
SECONDARY PRODUCTION THRESHOLDS

Secondary production threshold (1/3)

- **Bremsstrahlung photon emission:**
 - low energy photons (k small) will be emitted with high rate i.e. DCS $\sim 1/k$
 - generation and tracking of all these low energy photons would not be feasible (CPU time)
 - but low energy photons has a very small absorption length
 - If the detector spacial resolution is worst than this length (i.e. all volume boundaries are further), then the followings are *equivalent*:
 - **a:** generating and tracking these low energy photons till all their energy will be deposited
 - **b:** or just depositing the corresponding energy at the creation point (i.e. at a trajectory point)
 - note, that we think in energy scale at the model level that translates to length (spacial) at the transport level
 - a secondary production threshold might be introduced (either in energy or length)

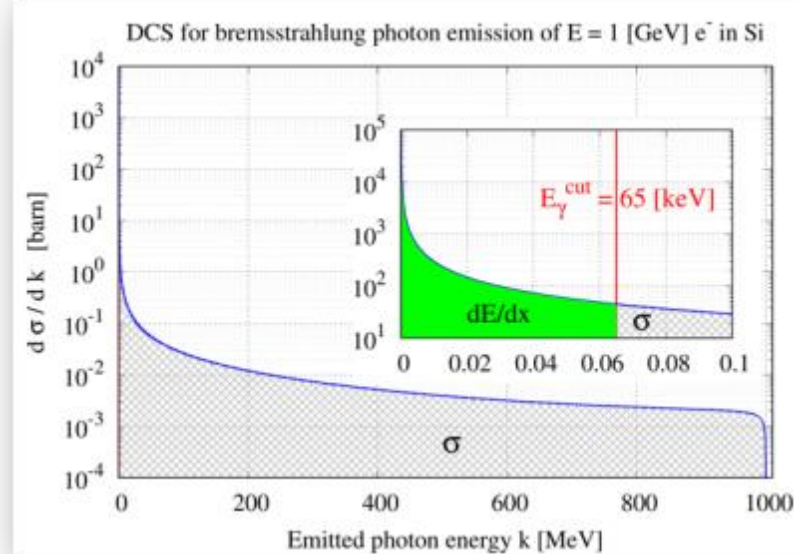


22 27. Passage of particles through matter



Secondary production threshold (2/3)

- Introduce secondary photon production threshold:
 - *secondary photons*, with initial energy below a gamma production threshold ($k < E_\gamma^{\text{cut}}$), are not generated
 - the corresponding energy (that would have been taken away from the primary) is accounted as *CONTINUOUS* energy loss of the primary particle along its trajectory



- Electron makes a step with a given length L , one can compute the mean energy loss (due to sub-threshold photon emissions) along the step as $L \times dE/dx$ (would be true only if $E = \text{const}$ along the step)

$$\frac{dE}{dx}(E, E_\gamma^{\text{cut}}, Z) = \mathcal{N} \int_0^{E_\gamma^{\text{cut}}} k \frac{d\sigma}{dk}(E, Z) dk$$

- *Secondary photons*, with initial energy above a gamma production threshold ($k > E_\gamma^{\text{cut}}$), are generated (*DISCRETE*)

$$\sigma(E, E_\gamma^{\text{cut}}, Z) = \int_{E_\gamma^{\text{cut}}}^E \frac{d\sigma}{dk}(E, Z) dk$$

- the emission rate is determined by the corresponding (restricted) cross section (σ)

Secondary production threshold (3/3)

- Secondary production thresholds in Geant4:
 - user needs to provide them in length (with a default value of 1.0 [mm]; 0.7 [mm] for the reference physics lists)
 - its proper value application dependent (size of the sensitive volume, CPU)
 - UI command: `/run/setCut 0.1 mm`
 - `/run/setCutForAGivenParticle e- 0.1 mm`
 - internally translated to energies at initialisation (depending on material and particle type)
 - the corresponding energy has a minimum value: default 1 keV but the user can set it
 - UI command: `/cuts/setLowEdge 500 eV`
 - production threshold defined for **gamma**, **e⁻**, **e⁺** and **proton** secondary particle types
 - **gamma** production threshold is used in bremsstrahlung while the **e⁻** in ionization
 - **e⁺** production threshold might be used in case of e-/e+ pair production
 - **proton** production threshold is used as a kinetic energy threshold for nuclear recoil in case of elastic scattering of *all hadrons and ions*
 - **gamma and e⁻** production thresholds might be used (optionally: `/process/em/applyCuts true`) in all discrete EM interactions producing such secondaries - Compton, Photoelectric, etc.
 - it's not mandatory to use production thresholds
 - however, high energy physics simulation would not be feasible without them !

EM PHYSICS CONSTRUCTORS

- A Physics list is the mandatory user class making the general interface between the physics the user needs and the Geant4 kernel
- List of particles: for which EM physics processes are defined
 - $\gamma, e^{\pm}, \mu^{\pm}, \pi^{\pm}, K^{\pm}, p, \Sigma^{\pm}, \Xi^{-}, \Omega^{-}, \text{anti}(\Sigma^{\pm}, \Xi^{-}, \Omega^{-})$
 - $\tau^{\pm}, B^{\pm}, D^{\pm}, D_s^{\pm}, \Lambda_c^{+}, \Sigma_c^{+}, \Sigma_c^{++}, \Xi_c^{+}, \text{anti}(\Lambda_c^{+}, \Sigma_c^{+}, \Sigma_c^{++}, \Xi_c^{+})$
 - $d, t, \text{He3}, \text{He4}, \text{Genericlon}, \text{anti}(d, t, \text{He3}, \text{He4})$
- The **G4ProcessManager** of each particle maintains a **list of processes**
- Geant4 provides several configurations of EM physics lists called **constructors** (**G4VPhysicsConstructor**) in the **physics_lists** library of Geant4
- These constructors can be included into a **modular Physics list** in a user application (**G4VModularPhysicsList**)

Geant4 standard EM Physics Constructors for HEP applications

- Description of Coulomb scattering:
 - e^{\pm} : Urban - MSC model below 100 [MeV] and the Wentzel - WVI + Single scattering (mixed simulation) model above 100 [MeV]
 - muon and hadrons: Wentzel - WVI + Single scattering (mixed simulation) model
 - ions: Urban - MSC model
- Different MSC stepping algorithms and/or parameters: speed v.s. accuracy

Constructor	Components	Comments
<code>G4EmStandardPhysics</code>	Default: nothing or <code>_EM0</code> (QGSP_BERT, FTFP_BERT,...)	for ATLAS and other HEP simulation applications
<code>G4EmStandardPhysics_option1</code>	Fast: due to simpler MSC step limitation, cuts used by photon processes (FTFP_BERT_EMV)	similar to one used by CMS; good for crystals but not good for sampling calorimeters (i.e. with more detailed geometry)
<code>G4EmStandardPhysics_option2</code>	Experimental: similar to option1 with updated photoelectric model but no-displacement in MSC (FTFP_BERT_EMX)	similar to one used by LHCb

Combined Geant4 EM Physics Constructors

- The primary goal is more the physics accuracy over the speed
- Combination of standard and low-energy EM models for more accurate physics description
- More accurate models for e^{\pm} MSC (Goudsmit-Saunderson(GS)) and more accurate stepping algorithms (compared to HEP)
- Stronger continuous step limitation due to ionisation (as others given per particle groups)
- Recommended for more accuracy sensitive applications: medical (hadron/ion therapy), space

Constructor	Components	Comments
<code>G4EmStandardPhysics_option3</code>	Urban MSC model for all particles	proton/ion therapy
<code>G4EmStandardPhysics_option4</code>	most accurate combination of models (particle type and energy); GS MSC model with Mott correction and error-free stepping for e^{\pm})	the ultimate goal is to have the most accurate EM physics description
<code>G4EmLivermorePhysics</code>	Livermore models for e^{-} , γ below 1 GeV and standard above; same GS MSC for e^{\pm} as in option4)	accurate Livermore based low energy e^{-} and γ transport
<code>G4EmPenelopePhysics</code>	PENELOPE models for e^{\pm} , γ below 1 GeV and standard above; same GS MSC for e^{\pm} as in option4)	accurate PENELOPE based low energy e^{-} , e^{+} and γ transport

Experimental Geant4 EM Physics Constructors

- Supposed to be used only by the developers for validations and model developments
- The main difference is in the description of the Coulomb scattering (GS, WVI, SS)

Constructor	Components	Comments
<code>G4EmStandardPhysicsGS</code>	standard EM physics and the GS MSC model for e^{\pm} with HEP settings	may be considered as an alternative to EM0 i.e. for HEP
<code>G4EmStandardPhysicsWVI</code>	WentzelWVI + Single Scattering mixed simulation model for Coulomb scattering	high and intermediate energy applications
<code>G4EmStandardPhysicsSS</code>	single scattering (SS) model description of the Coulomb scattering	validation and verification of the MSC and mixed simulation models
<code>G4EmLowEPPhysics</code>	Monarsh University Compton scattering model, 5D gamma conversion model, WVI-LE model	testing some low energy models
<code>G4EmLivermorePolarized</code>	polarized gamma models	a (polarized) extension of the Livermore physics models

USER INTERFACE TO EM PHYSICS

- EM parameters of any EM physics list may be modified at initialization of Geant4 using C++ interface to the `G4EmParameter` class or via UI commands
- Example of interfaces of `G4EmParameters`:
 - `SetMuHadLateralDisplacement()`
 - `SetMscMuHadRangeFactor()`
 - `SetMscMuHadStepLimitType()`
- Corresponding UI commands:
 - `/process/msc/MuHadLateralDisplacement`
 - `/process/msc/RangeFactorMuHad`
 - `/process/msc/StepLimitMuHad`
- Some other UI commands:
 - `/process/em/deexcitationIgnoreCut true`
 - `/process/eLoss/UseAngularGenerator true`
 - `/process/em/lowestElectronEnergy 50 eV`
 - `/process/em/lowestMuHadEnergy 100 keV`
 -

- Geant4 UI commands to define cuts and other EM parameters
- G4EmCalculator
 - easy access to cross sections and stopping powers (TestEm0)
- G4EmParameters
 - C++ interface to EM options alternative to UI commands
- G4EmSaturation
 - Birks effect (recombination effects)
- G4ElectronIonPair
 - sampling of ionisation clusters in gaseous or silicon detectors
- G4EmConfigurator
 - add models per energy range and geometry region
- G4NIELCalculator
 - Helper class allowing computation of NIEL at a step, which should be added in user stepping actions or sensitive detector (TestEm1)

How to extract Physics ?

- Possible to retrieve Physics quantities using a **G4EmCalculator** object
- Physics List should be **initialized**
- Example for retrieving the total cross section of a process with name **procName**, for **particle** and material **matName**

```
#include "G4EmCalculator.hh"
```

```
...
```

```
G4EmCalculator emCalculator;
```

```
G4Material* material =
```

```
  G4NistManager::Instance()->FindOrBuildMaterial(matName);
```

```
G4double density = material->GetDensity();
```

```
G4double massSigma = emCalculator.ComputeCrossSectionPerVolume  
  (energy,particle,procName,material)/density;
```

```
G4cout << G4BestUnit(massSigma, "Surface/Mass") << G4endl;
```

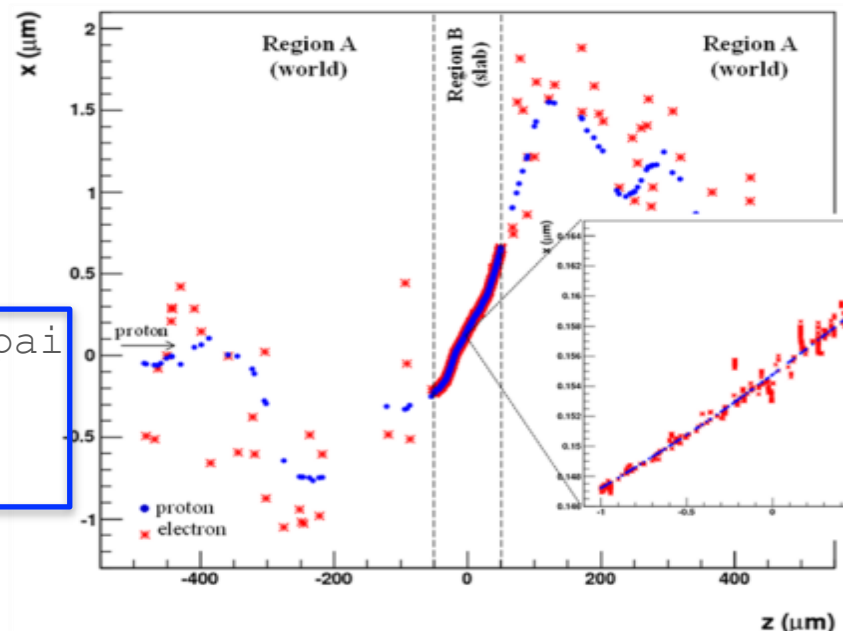
- A good example: [\\$G4INSTALL/examples/extended/electromagnetic/TestEm0](#)
Look in particular at the [RunAction.cc](#) class

SPECIAL EM TOPICS

Special EM topics: EM models per region

- Special EM models can be set to be used only in a given detector `G4Region`
- Example to use Geant4-DNA physics in a given detector region on the top of the standard EM physics:
 - the `G4EmConfigurator` can be used to add Geant4-DNA models
 - the DNA models are used only in the region B. for energies below 10 MeV
 - makes possible CPU and physics performance optimisation
 - the more accurate CPU intense simulation is done only in the region of interest
 - UI commands are available from Geant4 10.2 that allow easy configuration of some models per-region on the top of any EM constructor:

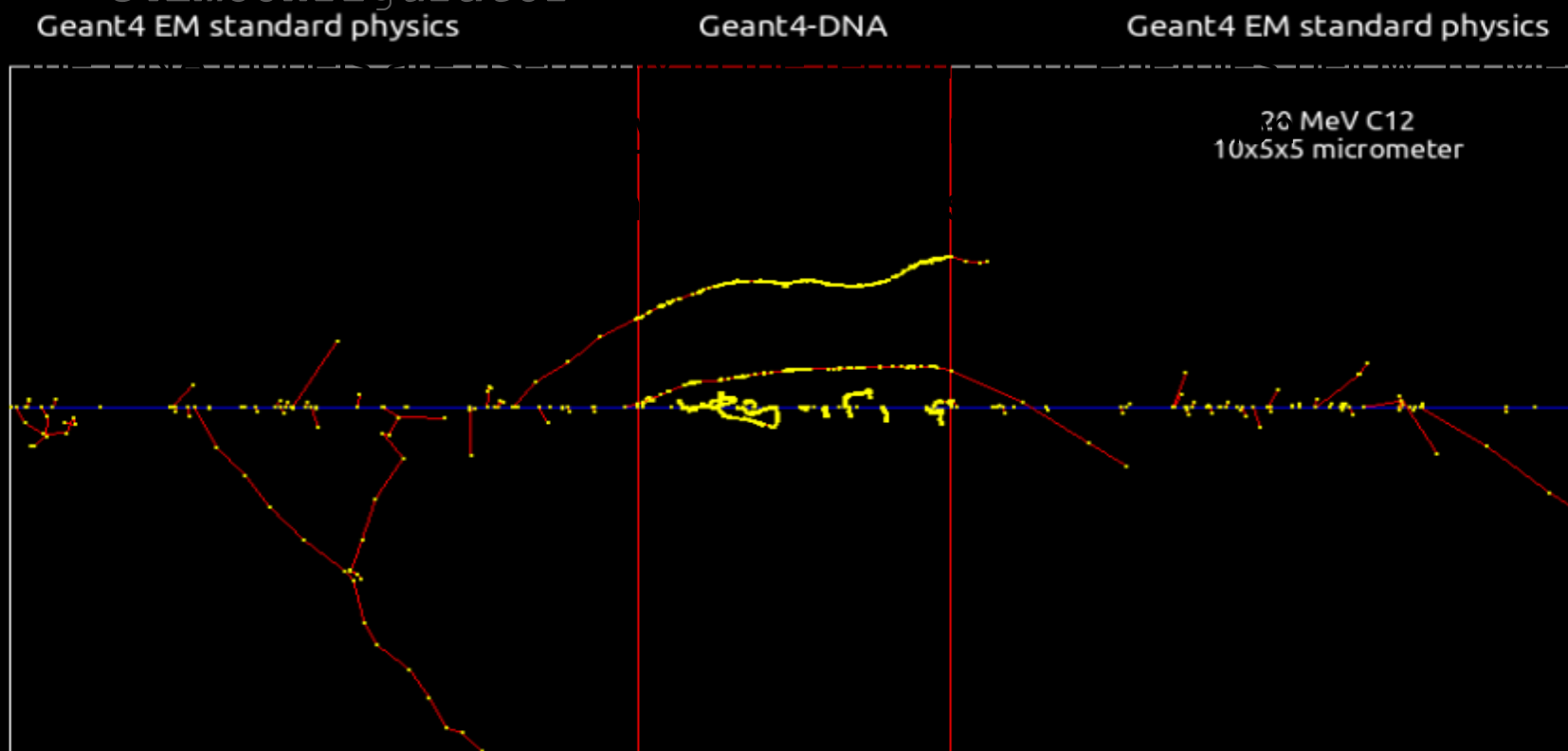
```
/process/em/AddPAIRegion proton MYREGION pai  
/process/em/AddMicroElecRegion MYREGION  
/process/em/AddDNARegion MYREGION opt0
```



Special EM topics: EM models per region

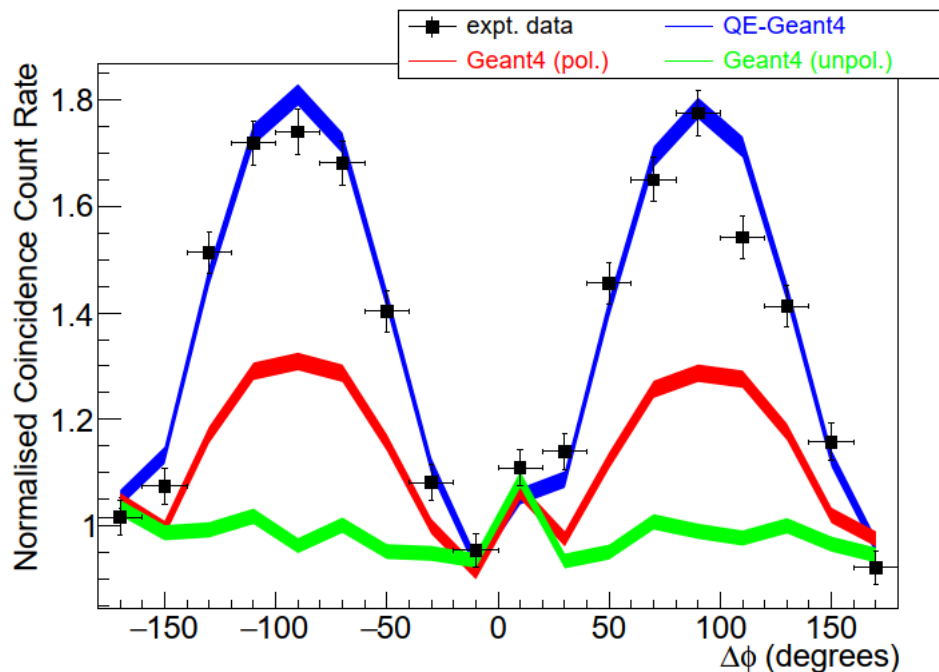
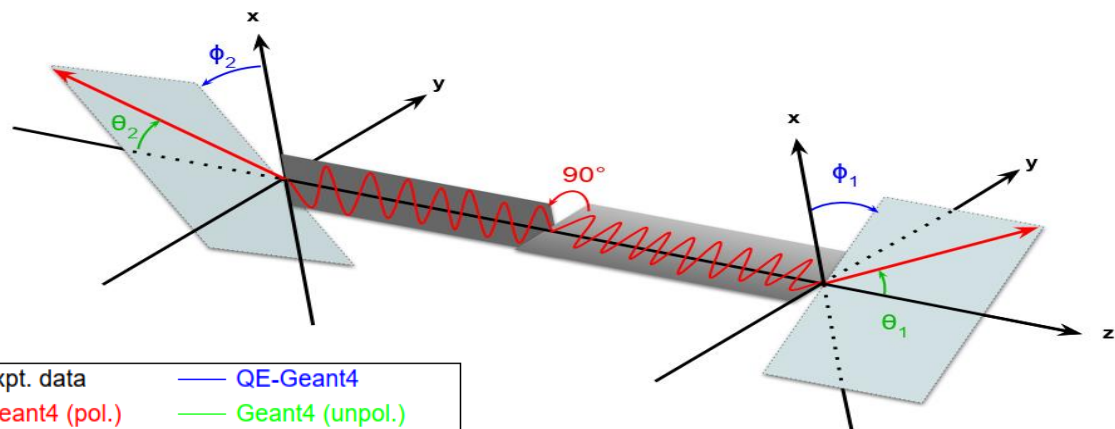
- Special EM models can be set to be used only in a given detector `G4Region`
- Example to use Geant4-DNA physics in a given detector region on the top of the standard EM physics:

the `microdosimetry` extended example:



Quantum entanglement in positron annihilation

(arXiv: 2012.04939v1)



- There is angular correlation for Compton scattering of two photons in PET device
- Geant4 method how simulate quantum effects has been developed by J. Allison
- The developed method may be potentially used in HEP

THANK YOU